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In Optical Engineering Vol. TT47)  
[Paperback] [2001] (Author) Alfred Kwok-  
Kit Wong**

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Steven R. J. Brueck and Xiaolan Chen "Spatial frequency analysis of optical lithography resolution enhancement techniques", Proc. SPIE 3679, Optical Microlithography

Resolution enhancement techniques (RETs) have, therefore, Resolution enhancement techniques for optical lithography and optical imaging theory Journal

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With the adoption of various combinations of resolution enhancement techniques (RET) for IC lithography, different process constraints are placed on the IC layout.

Title: Resolution enhancement techniques for optical lithography and optical imaging theory: Authors: Shibuya, Masato: Affiliation: AA(Optical Designing Headquarters

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Gary Kit Wong Person-Info (Ich bin Gary Kit Wong) Mutlangen M nchen London Vancouver

University of Texas at Austin Digital Repository Design and development of material-based resolution enhancement techniques for optical lithography

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forcing semiconductor manufacturers to extend the current 193 nm optical lithography systems The combined techniques include Resolution Enhancement

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